

ABSTRACT OF THE DISCLOSURESUPPORT FOR PART TO BE COATED BY ELECTROLYTIC
DEPOSITION

Mechanical holding contacts (10) are applied onto a part (4) located on a substrate (1) using a double actuating mechanism (11, 42) which closes the circle of contacts (10) before lowering them onto the surface of
5 the part (4). A good uniform contact is thus achieved. Contacts (10) may assure electrical potential. To be applied to coating by electrolysis.

Figure 1.